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SERIAL NO. **10/537238**LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION
DISCLOSURE STATEMENT

CH920010070US1 C17 Radcl PCT/PTO 31 MAY 200

(Use several sheets if necessary)

APPLICANT:

Emmanuel Delamarche, et al.

FILING DATE:

GROUP:

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

EXAMINE R INITIALS		DOCUMENT NUMBER	ISSUED DATE	NAME	CLASS	SUBCLAS S	FILING DATE (IF APPRO.)
/ME/	A1	6,089,853	07-18-00	BIEBUYCK ET AL			
	A2						
	A3						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLAS S	TRANSLATIO N	
							YES	NO
/ME/	B1	0 075 605 A1	25-09-81	EUROPE				X
/ME/	B2	WO 99/56878	11-11-99	PCT				X
/ME/	B3	WO 01/63241 A2	30-08-01	PCT				X

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

/ME/	C1	George M. Whitesides, et al, "Soft Lithography in Biology And Biochemistry", Annu. Rev. Biomed. Eng. 2001 pgs 335-373.
/ME/	C2	Mark Schena, "Microarray Biochip Technology", Eaton Publishing 2000
/ME/	C3	Jason T. Smith, "Spreading Diagrams for the Optimization of Quill Pin Printed Microarray Density", Langmuir 2002, 18, pgs 6289-6293.
/ME/	C4	IBM Technical Disclosure Bulletin, reference RD n446 Article 165 Page 1046, "Autonomous Displacement of a Solution in a Microchannel by Another Solution".
/ME/	C5	Bin Zhao, et al, "Surface-Directed Liquid Flow Inside Microchannels", Science, Vol 291, 9 February 2001, pgs 1023-1026.

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number	10537238
Filing Date	2005-05-31
First Named Inventor	Emmanuel Delamarche
Art Unit	1722
Examiner Name	
Attorney Docket Number	CH920010070US1

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Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
/ME/	1	6921514		2005-07-26	Vetter et al.	XXXXXXXXXX

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Not for submission under 37 CFR 1.99)</i>	Application Number	10537238
	Filing Date	2005-05-31
	First Named Inventor	Emmanuel Delamarche
	Art Unit	1722
	Examiner Name	
	Attorney Docket Number	CH920010070US1

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